

MEMC 02-0400 (3053)
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Lu et al.
Serial No. Not yet assigned
Filed July 21, 2003
Confirmation No. Not yet assigned
For METHOD TO MONITOR AND CONTROL THE CRYSTAL COOLING OR
QUENCHING RATE BY MEASURING CRYSTAL SURFACE TEMPERATURE

July 21, 2003

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VIRGINIA 22313-1450

SIR:

INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R. 1.97 and 1.98 and MPEP 609, and in compliance with the
duty of disclosure set forth in 37 C.F.R. 1.56, applicants submit copies of the references listed
* on the attached PTO/SB/08A for consideration by the Patent and Trademark Office in the above-
entitled application and to be made of record therein.

Respectfully submitted,



Robert M. Bain, Reg. No. 36,736
SENNIGER, POWERS, LEAVITT & ROEDEL
One Metropolitan Square, 16th Floor
St. Louis, Missouri 63102
(314) 231-5400

RMB/ROE/cjl

Express Mail Label No. EL 739384637 US

PTO/SB/08A INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
				Application Number	Not yet assigned
				Filing Date	July 21, 2003
				Confirmation Number	Not yet assigned
				First Named Inventor	Zheng Lu
				Group Art Unit	Not yet assigned
				Examiner Name	Not yet assigned
Sheet	1	of	1	Attorney Docket No.	MEMC 02-0400 (3053)

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code ² (if known)		
	1	5,178,720		Frederick	01/12/1993
	2	5,653,799		Fuerhoff	08/05/1997
	3	5,665,159		Fuerhoff	09/09/1997
	4	5,846,318		Javidi	12/08/1998
	5	5,882,402		Fuerhoff	03/16/1999
	6	6,503,322	B1	Schrenker et al.	01/07/2003

Examiner Signature		Date Considered	
-----------------------	--	--------------------	--

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached or place an "A" here if English language abstract is attached..

SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.